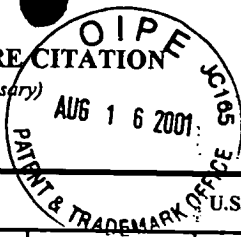


INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

(Z) 99069 P US

Application Number

PCT/EP99/09235

Applicant(s)

Schuster et al.

Filing Date

27/11/99

Group Art Unit

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
<i>RR</i>		DE 196 53 983 A1	21/12/96	Germany	G02B	13/24		✓
<i>RR</i>		EP 0 783 137 A2	09/11/96	European	G03F	7/20		✓
<i>RR</i>		DE 198 18 444 A1	24/04/98	Germany	G02B	13/18		✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>RR</i>		XP-0000882444 "Optical Lithography- Thirty Years and three orders of magnitude", 14 pgs.
<i>RR</i>		DD 299 017 A7, "Projektionsobjektiv", 5 pgs.,

EXAMINER

Deborah Raisen

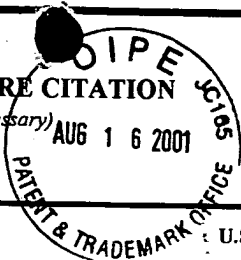
DATE CONSIDERED

May 16, 2003

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Docket Number (Optional)

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Application Number

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Filing Date

27/11/99

Group Art Unit

A4/IDS

U.S. PATENT DOCUMENTS

4-16-03

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DR		5,105,075	04/14/92	Ohta et al.	G01J	1/20	
DR		5,260,832	11/09/93	Togino	G02B	13/24	
DR		5,469,299	11/21/95	Nagano	G02B	21/02	
DR		5,448,408	09/05/95	Togino et al.	G02B	3/00	
DR		5,805,344	09/08/98	Sasaya et al.	G02B	13/04	

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
DR		EP 0 721 150 A2	10/07/96	European	G03F	7/20	✓	
DR		EP 0 770 895 A2	02/05/97	European	G02B	13/14	✓	
DR		EP 0 712 019 A2	15/05/96	European	G02B	13/24	✓	
DR		EP 0 742 492 A1	13/11/96	European	G03F	7/20	✓	
DR		EP 0 717 299 A1	19/06/96	European	G02B	13/24	✓	

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Reborah Kaiten

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PCT/EP99/09235

Applicant(s)
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